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IN THE UNITED STATES
PATENT AND TRADEMARK OFFICE

PATENT APPLICATION

Applicant: Noorbakhsh et al.

Case: 4150

Serial No.: 09/519,719

Filed: 03/07/00

Title: TEMPERATURE CONTROLLED SEMICONDUCTOR PROCESSING CHAMBER
LINER

THE COMMISSIONER OF PATENTS AND TRADEMARKS
Washington, D. C. 20231

S I R:

Disclosure Statement under 37 CFR 1.56 and 1.97(b)

Pursuant to 37 CFR 1.56, the documents listed on form PTO-1449, submitted herewith, are disclosed. Under rule 37 C.F.R. 1.98(a), the applicant submits that no specific comments are necessary for any of the cited English language publications.

Respectfully submitted

March 16, 2000
Date

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CERTIFICATE OF MAILING under 37 C.F.R. 1.8(a)

I hereby certify that this correspondence is being deposited on March 16, 2000 with the United States Postal Service as first class mail, with sufficient postage, in an envelope addressed to the Commissioner of Patents and Trademarks, Washington, D.C. 20231.

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